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### **Application Information**

Title Line One::  
Title Line Two:: SILICON CARBIDE SINTERED BODY AND  
Title Line Three:: METHOD FOR PRODUCING THE SAME  
Title Line Four::  
Total Drawing Sheets:: ---  
Docket Number:: 106659.01

### **Continuity Information**

>This application is a:: Rule 53(b) Divisional  
Application One:: 09/610,260  
Filing Date:: July 5, 2000  
Patent Number::  
which is a::  
>>Application Two::  
Filing Date::

09/610,260-030001

Patent Number::

**Prior Foreign Applications**

Foreign Application One:: 11-195708  
Filing Date:: July 9, 1999  
Country:: Japan  
Priority Claimed:: yes  
Foreign Application Two::  
Filing Date::  
Country::  
Priority Claimed::  
Foreign Application Three::  
Filing Date::  
Country::  
Priority Claimed::

0994167E-083001